PATENT

I hereby certify that on the date specified below, this correspondence is being sent via facsimile to (703) 746-3274, Attn: Examiner Eileen P. Morgan, Commissioner of Patents, Washington, DC 20231.

Date

Stephanie Jansen

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Trung Tri Doan and Scott E. Moore

Attorney Docket No.: 500084.05

Serial No. : 09/928,173

Group Art Unit

: 3723

Filed

: August 9, 2001

Examiner

: Eileen P. Morgan

Title

; METHOD AND APPARATUS FOR RELEASABLY ATTACHING A POLISHING

PAD TO A CHEMICAL-MECHANICAL PLANARIZATION MACHINE

Commissioner of Patents Washington, DC 20231

AMENDMENT

Applicants acknowledge receipt of the Office Action dated November 7, 2001.

In the Claims:

Please amend claims 89 and 91-94, and add new claims 99-110 as follows:

89.

A method for removably attaching a planarizing medium to (Amended)

a platen of a planarizing machine, comprising:

applying a signal to the platen that produces an electrostatic attractive force

between the platen and the planarizing medium.

The method of claim 89 wherein the platen includes a 91. (Amended) conductive plate positioned within the platen, and applying a signal includes providing a signal to the conductive plate positioned within the platen.